Atty. Docket No.: 042390.P7649C Patent

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of: Examiner: Chu, Gabriel L.

Suresh Marisetty Art Unit: 2114

Application No. 10/628,769 Confirmation No. 5779

Filed: July 28, 2003

For: SYSTEM ABSTRACTION LAYER

PROCESSOR ABSTRACTION

LAYER, AND OPERATING SYSTEM

**ERROR HANDLING** 

Mail Stop RCE Commissioner for Patents E-filed via EFS-Web

## REQUEST FOR CONTINUATION EXAMINATION (RCE) UNDER 37 C.F.R. §1.114

Sir:

In response to the Final Office Action mailed July 24, 2009, the Applicants respectfully request continued examination of the application and consideration of below remarks.

Appl. No.: 10/628,769 Amdt. dated 10/26/2009

Reply to Final Office action of 7/24/09